

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>				
<b>Filing Date:</b>				
<b>Title of Invention:</b>	PLASMA SOURCE COIL AND PLASMA CHAMBER USING THE SAME			
<b>First Named Inventor:</b>	Nam Hun KIM			
<b>Filer:</b>	Sungho Hong			
<b>Attorney Docket Number:</b>	4913-0002			
Filed as Small Entity				
<b>U.S. National Stage under 35 USC 371 Filing Fees</b>				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
Basic National Stage Fee	2631	1	150	150
Natl Stage Search Fee - Report provided	2642	1	200	200
Natl Stage Exam Fee - all other cases	2633	1	100	100
<b>Pages:</b>				
<b>Claims:</b>				
Claims in excess of 20	2615	26	25	650
Independent claims in excess of 3	2614	9	100	900
<b>Miscellaneous-Filing:</b>				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
Post-Allowance-and-Post-Issuance:				
<b>Extension-of-Time:</b>				
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>2000</b>